



AF/1763

[10191/1690]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. Serial No. : 09/762,985  
Title : DEVICE AND METHOD FOR  
ETCHING A SUBSTRATE USING  
AN INDUCTIVELY COUPLED PLASMA

Applicant(s) : Volker BECKER et al.

Filed : May 8, 2001

TC/A.U. : 1763

Examiner : Luz L. Alejandro Mula

Confirmation No. : 2674

Customer No. : 26646

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the  
United States Postal Service with sufficient postage as first class mail  
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Date: 1/6/2006

Signature: [Signature]

AARON C. DEDITCH  
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**TRANSMITTAL AND PETITION**  
**TO EXTEND PURSUANT TO 37 C.F.R § 1.136(a)**

SIR:

Transmitted herewith for filing in the above-identified patent application is an  
Amendment After A Final Office Action.

This is also a Petition pursuant to 37 C.F.R. § 1.136(a) to extend the three-month  
response date to the Final Office Action mailed on September 19, 2005 by one month from  
December 19, 2005 to January 19, 2006.

Please charge the appropriate fee, which is believed to be \$120.00, to Deposit  
Account No. 11-0600. The Commissioner is also authorized to charge any additional fees  
(including any extension fees) or credit any overpayment to Deposit Account No. 11-0600.  
Two duplicate copies of this transmittal letter and petition are enclosed for that purpose.

Respectfully submitted,  
KENYON & KENYON LLP

Dated: 1/6/2006

By: [Signature]

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